



Attorney Docket 0524-0136.01

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
Tomotaka Yokoyama et al. )  
Serial No.: 10/761,771 )  
Filed: January 20, 2004 )  
For: Management Technique Of Friction )  
Coefficient Based On Surface Roughness,)  
Substrate For An Information Recording)  
Medium, Information Recording Medium)  
And Manufacturing Method Thereof )  
Art Unit: 1773 )  
Examiner: Leszek B. Kiliman )

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 2/14/06  
Signature Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT B**

Sir:

In response to the Office Action of August 15, 2005, a three month extension of time being submitted herewith, please amend the above-identified application as follows: